In accordance with the guidelines and waived provisions of 37 C.F.R. 1.121 promulgated in the USPTO announcement of January 31, 2003, please make the following amendments.

IN THE SPECIFICATION:

Before the first line of the specification, please replace the current title of the invention with the following new title of the invention:

METHOD FOR MANUFACTURING SEMICONDUCTOR AND METHOD
FOR MANUFACTURING SEMICONDUCTOR DEVICE METHOD FOR
MANUFACTURING SEMICONDUCTOR LASER OPTICAL DEVICE